		1
1	39. (New)	A semiconductor laser according to Claim 1,
2		wherein the current-blocking layer is comprised of at least one of
3	AlInP and (Al _x Ga _{1-x})	yIn _{1-y} P, where 0.7 <x<1 and="" y="0.5.</td"></x<1>
1	40. (New)	A semiconductor laser according to Claim 12,
2		wherein the current-blocking layer is comprised of at least one of
3	AlInP and $(Al_xGa_{1-x})yIn_{1-y}P$, where 0.7 <x<1 <math="" and="">y=0.5.</x<1>	
1	41. (New)	A semiconductor laser according to Claim 25,
2		wherein the current-blocking layer is comprised of at least one of
3	AlInP and $(Al_xGa_{1-x})yIn_{1-y}P$, where 0.7 < x < 1 and y = 0.5.	
1	42. (New)	A semiconductor laser according to Claim 35,
2		wherein the current-blocking layer is comprised of at least one of
3	AlInP and (Al _x Ga _{1-x})yIn _{1-y} P, where 0.7 <x<1 and="" y="0.5.</td"></x<1>	
1	43. (New)	A semiconductor laser according to Claim 36,
2		wherein the current-blocking layer is comprised of at least one of
3	AlInP and (Al _x Ga _{1-x})	$yIn_{1-y}^{yI}P$, where 0.7 <x<1 and="" y="0.5.</td"></x<1>